

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 10/071,425
Priority Filing Date February 8, 2002
 Inventor Terry L. Gilton et al.
 Assignee Micron Technology, Inc.
Priority Group Art Unit 2813
Priority Examiner Thanhha S. Pham
 Attorney's Docket No. MI22-2440
 Customer No. 021567
 Title: Semiconductor Processing Method Using Photoresist and an
 Antireflective Coating

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
 Commissioner for Patents
 P. O. Box 1450
 Alexandria, VA 22313-1450

VIA EXPRESS MAIL

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)
 Wells St. John P.S.
 601 West First Avenue, Suite 1300
 Spokane, WA 99201-3828

Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS